

PALM Intranet

Application
Number

SEARCH

IDS Flag Clearance for Application 10629069

IDS
Information

Content	Mailroom Date	Entry Number	IDS Review	Reviewer
M844	07-29-2003	14	<input checked="" type="checkbox"/>	08-10-2005 22:35:27 IDS CONV

UPDATE

Refine Search

Search Results -

Terms	Documents
6313481	11

Database:

US Pre-Grant Publication Full-Text Database
 US Patents Full-Text Database
 US OCR Full-Text Database
 EPO Abstracts Database
 JPO Abstracts Database
 Derwent World Patents Index
 IBM Technical Disclosure Bulletins

Search:

L13

Search History

DATE: Tuesday, March 07, 2006 [Printable Copy](#) [Create Case](#)

<u>Set Name</u> side by side	<u>Query</u>	<u>Hit Count</u>	<u>Set Name</u> result set
---------------------------------	--------------	------------------	-------------------------------

DB=USPT; PLUR=YES; OP=OR

<u>L13</u>	6313481	11	<u>L13</u>
<u>L12</u>	6303483	13	<u>L12</u>
<u>L11</u>	6088070	20	<u>L11</u>
<u>L10</u>	5923962	281	<u>L10</u>
<u>L9</u>	5923962	281	<u>L9</u>
<u>L8</u>	5923963	18	<u>L8</u>
<u>L7</u>	5913100	4	<u>L7</u>
<u>L6</u>	5738948	4	<u>L6</u>
<u>L5</u>	5738948L4	0	<u>L5</u>
<u>L4</u>	5643826	466	<u>L4</u>
<u>L3</u>	5594569	140	<u>L3</u>
<u>L2</u>	6,281,057	6	<u>L2</u>
<u>L1</u>	5,504,020	28	<u>L1</u>

Refine Search

Search Results -

Terms	Documents
5504020 and (tungsten)	10

Database:

US Pre-Grant Publication Full-Text Database
US Patents Full-Text Database
US OCR Full-Text Database
EPO Abstracts Database
JPO Abstracts Database
Derwent World Patents Index
IBM Technical Disclosure Bulletins

Search:

Search History

DATE: Tuesday, March 07, 2006 [Printable Copy](#) [Create Case](#)

Set Name Query

side by side

Hit Count **Set Name**
result set

DB=USPT; PLUR=YES; OP=OR

L13 5504020 and (tungsten)10 L13

DB=PGPB; PLUR=YES; OP=OR

L12 L11 and (gate and tungsten)37 L12L11 ((gate near4 resist) near10 (mask near5 impurit\$5))85 L11

DB=USPT; PLUR=YES; OP=OR

L10 L9 and ((gate near4 resist) near10 (mask near5 impurit\$5))19 L10L9 L6 and (gate near10 tungsten)148 L9L8 L6 and (gate near5 tungsten)86 L8L7 L6 and (gate and tungsten)462 L7L6 L2 and method1020 L6L5 L2 andd method2309983 L5L4 L2 andd method2309983 L4L3 L2 andd method2309983 L3L2 (ion or impurity) same ((gate near7 resist) near5 mask)1043 L2

L1 (ion or impurity) same ((gate near7 resist) near10 mask)

1139 L1

END OF SEARCH HISTORY